

Form 1449 (Modified)				Atty. Docket No. HIT1P022/ HSJ9-2003-0129US1	Application No.: Unassigned 10/672,896
Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)				Applicant: Quang Le et al.	Group Art Unit: Unassigned 3729
				Filing Date: Herewith	

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Examiner /Tai Nguyen/		Date Considered 06/08/2006		

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			Filing Date: 09/26/2003	Group Art Unit: 3729

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N								
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Examiner		Date Considered		06/08/2006

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



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							Yes	No
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N								
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